

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor application of: Sarver et al.

Application No.: 10/727,188

Filed: December 2, 2003

Title: METHOD AND APPARATUS FOR
STACKING SEMICONDUCTOR WAFERS

Attorney Docket No.:
NSC1P286/P05740

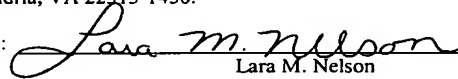
Examiner: Unassigned

Group: Unassigned

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on October 12, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:


Lara M. Nelson

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. This application was filed on December 2, 2003, and no response has been received as of this date.

Respectfully submitted,
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